

GET (3519TT) grinding technology was granted Patents in U.S., Japan, Germany, China and Taiwan

Dear investors and analysts:

We would like to share with you that GET (3519TT) was granted patent by the U.S. Patent and Trademark Office for the Company's invention on "position adjustment mechanism of grinding wheels." The grinding technology, which enables GET to decrease manufacturing costs and increase yield rate, was granted patents also in Japan, Germany, China and Taiwan.

The use of grinding wheels has been widely adopted in solar slicing to proceed with mirror grinding for work pieces. Generally it needs to perform in sequences a tough grinding then a fine grinding to polish work pieces smooth as desired. To well control quality and yield, the procedure needs to take many variables into account over again, including dynamic balance, concentricity, and roundness of grinding wheel. GET simplifies the time-consuming multiple processes with the invention of "position adjustment mechanism for grinding wheels." With the proprietary structure, one single device can control different grinding wheels, while rough and fine grindings can be done within a same process. The invention not only increase yield rate, but also save power and facility costs.

The proprietary technology has been granted patents in U.S., China, Japan, Germany and Taiwan. Most of the countries are top markets in solar business. As tier one multi-wafer maker, GET will keep developing high conversion wafer with lower cost, to cooperate with tier-1 partners and increase global sales.

Thank you for your attention.

Best Wishes,
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